

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re U.S. Patent Application of)
TAMAKI et al.)
Application Number: To be Assigned)
Filed: Concurrently Herewith)
For: SEMICONDUCTOR DEVICE AND METHOD FOR)
FABRICATING THE SAME)
Attorney Docket No. HITA.0445)

Honorable Assistant Commissioner for Patents
Washington, D.C. 20231

PRELIMINARY AMENDMENT

Sir:

Prior to an examination on the merits, please amend the above-identified application
as follows: